

Docket No.: 50090-306

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PATENT

AF 12823
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
BEFORE THE BOARD OF PATENT APPEALS AND INTERFERENCES

Pre Application of

Hiroshi TOBIMATSU, et al.

Serial No.: 09/910,824

Filed: July 24, 2001

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING
PASSIVATION FILM AND BUFFER COATING FILM

NOTICE OF APPEAL
FROM THE PRIMARY EXAMINER
TO THE BOARD OF APPEALS

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant(s) hereby appeal(s) to the Board of Appeals from the decision dated June 18, 2003
of the Primary Examiner finally rejecting claims 1 through 4 and 6.

Appeal Fee: \$330.00

- Not required (fee paid in prior appeal in this application).
 Charge to Deposit Account No. 500417.
 Check Enclosed.

Respectfully submitted,

10/20/2003 HDEMESS1 00000046 500417 09910824

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MCDERMOTT, WILL & EMERY

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Date: October 17, 2003